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DNA-Decorated Carbon Nanotubes as Sensitive Layer for AlN Contour-Mode Resonant-MEMS Gravimetric Sensor

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Abstract
In this work a nano-enabled gravimetric chemical sensor prototype based on single-stranded DNA (ss-DNA) decorated single-walled carbon nanotubes (SWNT) as nano-functionalization layer for Aluminun Nitride (AIN) contour-mode resonant-MEMS gravimetric sensors has been demonstrated. Two resonators fabricated on the same silicon chip and operating at different resonance frequencies, 287 and 450 MHz, were functionalized with this novel bio-coating layer to experimentally prove the capability of two distinct single strands of DNA bound to SWNT to enhance differently the adsorption of volatile organic compounds such as dinitroluene (DNT, simulant for explosive vapor) and dymethyl-methylphosphonate (DMMP, a simulant for nerve agent sarin). The introduction of this bio-coating layer addresses the major drawbacks of recovery time (50% recovery in less than 29 seconds has been achieved) and lack of selectivity associated with gas sensor based on polymers and pristine carbon nanotube functionalization layers.

Keywords
carbon nanotubes, chemical sensors, density measurement, DNA, carbon nanotubes, contour-mode resonant-MEMS gravimetric sensor, nano-enabled gravimetric chemical sensor prototype, sensitive layer

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DNA-DECORATED CARBON NANOTUBES AS SENSITIVE LAYER FOR
AIN CONTOUR-MODE RESONANT-MEMS GRAVIMETRIC SENSOR

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ABSTRACT

In this work a nano-enabled gravimetric chemical sensor prototype based on single-stranded DNA (ss-DNA) decorated single-walled carbon nanotubes (SWNT) as nano-functionalization layer for Aluminum Nitride (AIN) contour-mode resonant-MEMS gravimetric sensors has been demonstrated. Two resonators fabricated on the same silicon chip and operating at different resonance frequencies, 287 and 450 MHz, were functionalized with this novel bio-coating layer to experimentally prove the capability of two distinct single strands of DNA bound to SWNT to enhance differently the adsorption of volatile organic compounds such as dinitrofluorobenzene (DNFB, simulant for explosive vapor) and dymethyl-methylphosphonate (MMP, a simulant for nerve agent sarin).

The introduction of this bio-coating layer addresses the major drawbacks of recovery time (50% recovery in less than 29 seconds has been achieved) and lack of selectivity associated with gas sensor based on polymers and pristine carbon nanotube functionalization layers.

I. INTRODUCTION

The development of miniaturized smart sensors for real time detection of chemical and biological species has recently been a research topic of primary interest due to the growing number of applications ranging from national safety to medical diagnostics and industrial emission monitoring.

The implementation of high performance gravimetric gas sensors for detection of multiple Volatile Organic Chemicals (VOCs) requires both a high quality transducer and an excellent chemically active adsorbent layer.

Among the wide variety of transducers suggested for chemical sensing, gravimetric sensors based on piezoelectric resonators represent an established category suitable for a broad range of analytes including less polar chemical vapors that generally cannot be effectively sensed by conductance based sensors [1].

MEMS/NEMS devices show great potential as gravimetric sensors since their reduced size and frequency of operation higher than conventional quartz crystal microbalance (QCM) permit them to achieve unprecedented value of mass sensitivity and limit of detection. Although promising, there are still some unsolved challenges related to their effective employment as VOC sensors. For instance, nanocantilever beam based sensors suffer from the greatly reduced size of the area dedicated to the adsorbent layer, which limits the overall mass that can be adsorbed in the presence of a given analyte concentration in the environment. Thin film bulk acoustic resonators (FBAR) can attain high values of sensitivity to adsorbate concentration thanks to their high working frequency and wider area dedicated to sensing, but they cannot provide for different frequencies of operation on the same die, therefore posing a limitation in the realization of a micromechanical nose with extended sensitivity range.

In this perspective, the AIN MEMS resonant transducer of this work (Fig. 1) represents a combination of the key advantages previously demonstrated in MEMS/NEMS technologies. In fact, the AIN resonators have shown very high experimentally-verified sensitivity [2], enhanced effective area dedicated to sensing and the ability to achieve a very wide dynamic range (up to 8 orders of magnitude in sensitivity) by having multiple frequencies on the same chip.

In regards to the adsorbent layer, a wide range of nanoengineered materials have been extensively studied and employed [1]. Among those, Single Wall Carbon Nanotubes (SWNTs) stand out as prime candidates for sensing applications because their peculiar hollow structure and large surface to volume ratio greatly enhances their adsorptive capacity. In particular, SWNT bundles offer a great advantage over polymeric films, since they provide the transducer with a larger number of adsorbing sites distributed along two dimensions and therefore enable a quick and reversible adsorption process that solely involves the device surface. In general, this cannot be achieved with polymers, for which the adsorption process occurs within the bulk of the film and is consequently associated with a slower response time.

Generally, the use of bare carbon nanotubes as nonsensitive layer is not sufficient to address the problem of selectivity, since SWNTs are very sensitive to a broad target of molecules. In order to overcome the lack of specificity posed by pristine SWNTs, covalent and
non-covalent functionalization layers have been employed. SWNTs have been coated by different layers such as chemo-selective polymers [3], enzyme [4], and metal nanoclusters [5]. Although promising, most of these techniques cannot be applied on a large scale and do not allow functionalizing adjacent transducers on the same chip with different chemical coatings. These factors pose an essential limitation to the realization of an on-chip electronic nose.

A novel nano-functionalizing bio-coating constituted by single stranded DNA (ss-DNA) has been successfully demonstrated for SWNT-based FET devices [6]. This technology sets a very promising pathway for the deployment of electronic noses, but it has never been investigated for gravimetric sensor.

In this paper, in order to overcome the common limitations of gas sensor based on pristine CNTs, DNA-decorated SWNT are employed as adsorbent layer for AlN counter-mode resonant sensors. Two resonators fabricated on the same die and operating at different resonance frequencies, 287 and 450 MHz, were functionalized with this novel bio-coating layer consisting of SWNTs grown by CVD and two distinct sequences of ss-DNA. Such sensors were tested for gas species such as dinitrobenzene, DNT, a simulant for explosive vapor and dimethyl-methylyphosphonate, DMMP, a simulant for nerve agent sarin, demonstrating a net enhancement in the adsorption of both chemical agents. The analytes employed in this work responded differently to the same strand leading up to an 8 fold enhancement in DNT detection using one sequence of ss-DNA and a 2-3 times increase in both species detection when a second sequence was used.

II. DESIGN DETAILS AND FABRICATION
Sensor Transduction Mechanism

In an AlN counter-mode resonator, where \( W \), \( L \) and \( T \) are respectively width, length and thickness of each sub-device (Fig. 2), the application of an electric field across the film thickness produces an in-plane dilatation through the equivalent \( d_{31} \) coefficient and excites the resonator into lateral contour-extensional vibrations. The frequency of operation is approximately set by the width of a single sub-resonator, \( W \):

\[
f_0 = \frac{1}{2W} \sqrt{\frac{E_0}{\rho_0}}
\]

where \( E_0 \) and \( \rho_0 \) represents the Young’s modulus and the density of the resonator.

As previously demonstrated [2], the resonator is best operated as a sensor and attains highest sensitivity when the adsorption layer is placed on its top surface. The large area available renders the resonator extremely sensitive to analyte concentration according to the following equation:

\[
S_{eff} = -\frac{f_0^2}{\sqrt{E_0 \cdot \rho_0 \cdot \frac{W}{T}}} [\text{kHz}\cdot\text{um}^2/\text{fg}]
\]

where \( S_{eff} \) is the effective sensitivity to analyte concentration of a higher order contour mode resonator. For this kind of piezoelectric transducers the \( W/T \) ratio plays a key role, since it is generally greater than 1 and clearly advantageously improves the device sensitivity.

In this work, two devices with frequencies of operation of 287 MHz (\( T = 2\mu m \), \( W = 15\mu m \), \( L = 200\mu m \), \( n = 5 \)) and 450 MHz (\( T = 2\mu m \), \( W = 10\mu m \), \( L = 200\mu m \), \( n = 5 \)) were fabricated on the same chip and tested by exposing them to different concentration of analytes. The devices have experimentally confirmed sensitivities to analyte concentration of 17.1 and 27.4 kHz·um²/fg, which are in close agreement with analytically derived values (17.3 kHz·um²/fg and 28 kHz·um²/fg, respectively). With a device frequency accuracy of 1 ppm (ultimately affected by device \( Q \)) a minimum mass density of 16 ag/μm² can be resolved by these devices.

Furthermore, recent experimental work [8] on AlN contour-mode resonators has demonstrated devices operating at 7.23 GHz with \( Q \) of 630, proving that even higher sensitivities and Figure of Merit (FOM= \( fQ \times 4 \times 10^{12} \)) can be achieved.

Fabrication

The fabrication process employed to realize the nano-enabled sensor essentially consists in the combination of top-down microfabrication techniques for the resonator [9] and bottom-up growth of SWNTs by catalytic Chemical Vapor Deposition (CVD) as presented in Figure 2.

![Figure 2: Basic geometry of a higher order laterally vibrating AlN resonator. In this case the number of sub-resonators, \( n \), is 3.](image)

![Figure 3: Fabrication process: a) sputter deposition of Pt bottom electrode and AlN on Si and LSN; b) open via in AlN, lithographic patterning of sputtered Pt as top electrode, dry etching of AlN in Cl₂ based chemistry; c)](image)
sputter deposition of oxide and evaporation of iron catalyst; d) SWNTs growth by catalytic CVD at 900 °C in methane containing atmosphere; e) spinning of PMGI + photoresist, development and dry etching of SiO2 in CF4 based chemistry; f) XeF2 dry release of AlN resonator; g) PMGI + photoresist removal.

The direct integration of SWNTs was performed at the die level immediately before the release of the device from the Si substrate by XeF2 dry etching. PMGI patterned by standard lithographic techniques protected the body of the resonator during the oxide etching in CF4 chemistry. This step removed the oxide seed layer and SWNTs from every other region of the die but the device body.

The process of integration described above has been performed at the die level because the dimension of the available CVD reactor cannot accommodate a 4-inch wafer substrate, but it can be easily extended to large scale manufacturing [7].

The functionalization of the adsorbent layer represents the last step of the process and it took place after the device fabrication. The single stranded DNA sequences chosen as functionalizing agents were:

Seq 1: 5' GAC TCT GTG GAG GAG GTA GTC 3'
Seq 2: 5' CTT CTG TCT TGA TGT TTG TCA AAC 3'

and were applied respectively to the 450 MHz and 287 MHz resonators. The functionalizing agents were obtained from Invitrogen (Carlsbad, CA) and diluted in distilled water to make a solution of 100 μM. The DNA solution was applied on the device with a micropipette for 45 minutes in a humid environment and hence dried in a nitrogen stream (Fig 1, 3).

III. EXPERIMENTAL RESULTS

The sensors were exposed to varying concentrations of DNT and DMMP before and after the ss-DNA functionalization of the SWNTs adsorbent layer.

Mass flow controllers regulated the flow of high purity argon carrier gas through two lines, one dedicated solely to the carrier, and a second one merged into a bubbler through which the analyte flow was generated. The two lines recombined the flow immediately before the testing chamber inlet so that different concentrations of the analytes were produced by controlling the relative flow of the two lines. The total flow delivered in the testing chamber was kept at a constant rate of 1000 secm. The sensors were refreshed by solely flowing argon inside the testing chamber at the end of each analyte delivery phase. A complete testing cycle was hence formed by sequencing both analyte and refresh phases of identical duration (285 seconds each). A Labview controlled system of two and three-way solenoid valves switched the flows so that the two phases were automatically alternated.

The die under test was attached to a custom designed PCB that is provided with on-board calibration standards and served as a lid for the testing chamber. The resonators were wirebonded to 50 Ω lines and the analytes-induced frequency shift were monitored by an Agilent® N5230A Network Analyzer connected to the PCB.

As mentioned above, the effect of two distinct single strands of DNA as functionalizing agents for SWNTs have been investigated. Analyte concentrations equal to 10, 25 and 50 % of the saturated vapor pressure were delivered on both sensors.

In order to observe the effect of the nanofunctionalization layer, the sensor response was characterized for the same analytes with just bare SWNTs and after the application of ss-DNA.

Figure 4: Response to DNT of a 450 MHz AlN contour-mode resonator with and without DNA seq.1 functionalization. The sensor is refreshed to its original state by flowing Ar. No external heating is required and 50% recovery is achieved in 28.5 seconds.

Figure 5: Response to DMMP of a 287 MHz AlN Contour-Mode resonator with and without DNA seq.2 functionalization.
The ss-DNA nano-enabled resonant sensor at 287 MHz and functionalized with sequence 2 exhibited a clear improvement in the response to both chemical agents. Differently, in this case, no substantial diversification in the response to DNT and DMMP was recorded; in fact, both species adsorption was amplified by a factor of nearly 2-3 folds over the bare SWNT-coated resonator.

During the refresh phase both sensor responses recovered at least 50% of their initial value in approximately 28.5 seconds, demonstrating that the sensor is reversible.

Although the adsorption mechanism is not fully understood and further investigations are needed, from the previous results it can be inferred that the DNA nano-coating layer increases the binding affinity between the analyte and the SWNT absorbent layer, therefore enhancing the amount of adsorbed mass for a given concentration.

The amount of mass adsorbed on the nano-sensitive layer for each analyte concentration has been estimated from the change in the motional inductance of the extracted MBVD circuit (Fig.6). The adsorbed mass, $\Delta m$, is modeled by a series motional inductance, $Lm^*$, proportional to the adsorbed mass and a series resistance, $Rm^*$, that takes into consideration the small additional damping introduced by the adsorption process:

$$\Delta m = 2 \cdot n \cdot Lm^* \cdot \eta^2 \quad (3)$$

where $\eta$ is the electromechanical coupling coefficient of the resonator ($\eta = 2d_3^2E/L$).

The estimated VOC mass adsorbed for 10% concentration of both analytes is reported in Figure 7, where the diversification in the affinity to different chemical species clearly points out that the adsorption process is DNA sequence dependent.

After the application of the DNA solution, a decrease in $Q$ factor of approximately 10% (considering the value of $Q$ after flowing Ar) was recorded for both devices. The partially aqueous environment created by the addition of DNA is considered the primary cause of this additional damping. No change in the off-resonance capacitance was observed, while $Rm$ slightly increased (approximately 10% of its original value) reflecting the corresponding drop in $Q$.

### IV. CONCLUSION

A novel nano-enabled gravimetric chemical sensor prototype based on ss-DNA decorated SWNTs on AlN contour-mode MEMS resonator has been designed, fabricated and tested.

![Figure 7: Comparison between DNT and DMMP response with different ss-DNA functionalization sequences for 10% analyte concentration. The chart shows the enhanced mass adsorption occurred because of the functionalization process and the ability to selectively distinguish between DNT and DMMP.](image)

The novel functionalization layer permits to achieve up to an 8 fold increase in sensitivity to DNT over bare nanotubes with 1 sequence of DNA, and a 2-3 fold enhancement to both DNT and DMMP when a second sequence is employed. This work constitutes the first experimental verification towards the demonstration of a highly selective nanomechanical nose, whose realization will be made possible by gaining access to a vast ss-DNA library.

### REFERENCES


